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Attorney Docket No.: 018419-008710US

#11/B
OKON
PATENT
3/5/03

On February 13, 2003

TOWNSEND and TOWNSEND and CREW LLP

By: [Signature]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Sien G. Kang et al.

Application No.: 09/710,628

Filed: November 8, 2000

For: IMPROVED TREATMENT
METHOD OF FILM QUALITY FOR
THE MANUFACTURE OF
SUBSTRATES

Examiner: Shrinivas H. Rao

PRELIMINARY AMENDMENT

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Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Final Office Action mailed 9/13/2002, please amend this application as follows:

IN THE CLAIMS:

Please amend claim 16 as follows:

16. The method of claim 1 wherein said deposition species comprise a species selected from SiH_4 , $\text{Si}_x\text{Cl}_y\text{H}_z$, and SiCl_x .

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